



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Saka et al.

Serial No. 10/029,080

Filed: December 21, 2001

Title: In-Situ Method and Apparatus for End  
Point Detection in Chemical Mechanical  
Polishing

Examiner: To be assigned

Art Unit: To be assigned

Date: March 12, 2002

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CERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on March 12, 2002.

Signed:

Mari Bateman

INFORMATION DISCLOSURE STATEMENT

Box: DD

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

This Information Disclosure Statement is hereby submitted in accordance with 37 CFR 1.98 and pursuant to Applicant's continuing duty under 37 CFR 1.56 to bring any information which may be material to patentability of this application to the Examiner's attention.

Applicant makes no representation that a complete search has been conducted by the Applicant, or that there is not possibly more relevant art. Applicant also makes no representation that the information submitted herewith is in fact material. The subject application is believed patentable over any of the references listed on the attached PTO 08A form. This Information Disclosure Statement is being filed before the mailing date of a first Office action on the merits in accordance with 37 C.F.R. §1.97(b)(3); accordingly, no fees are required. However, the Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No.06-1300 (Order No. A-69174-1/MSS).

Respectfully submitted,

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